

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Armin Kubelbeck et al.

Examiner: Empie, Nathan

Serial No.: 10/526,497

Group Art Unit: **1709**

Filed: March 4, 2005

Title: Etching Pastes for Silicon Surfaces

AMENDMENT AND RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed 4 October 2009, please amend the application and consider the remarks that follow:

Remarks/Arguments begin on page 2 of this paper.